

Based on Form PTO-1449 (3/90) LIST OF REFERENCES CITED BY APPLICANT (Use several sheets if necessary)	ATTY. DOCKET NO. 674556-2003.1	SERIAL NO. 10/024,658
	APPLICANT CHOY et al.	
	FILING DATE December 7, 2001	GROUP 1762

U.S. PATENT DOCUMENTS

EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO
88	AL	0 103 505 A1 ✓	3/21/84	EUROPE				
10	AM	0 252 755 A1 ✓	1/31/88	EUROPE				
8	AN	DE 43 32 890 A1 ✓	3/24/94	GERMANY				

OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)

88	AO		✓	Ryu et al., "Fabrication of ZnO thin films using charged liquid cluster beam technique", Applied Physics Letters, vol., 67, no. 22, pp. 3337-3339, 27 November 1995				
	AP		✓	Salata et al., "Fabrication of CdS nanoparticles embedded in a polymer film by gas-aerosol reactive electrostatic deposition technique", Thin Solid Films, vol. 251, no. 1, pp. 1-3, 15 October 1994				
	AQ		✓	Yiguie et al., "Chemical Vapor Deposition at Low Temperatures", Journal of the Electrochemical Society, vol. 122, no. 4, pp. 585-588, 1 April 1975				
8	AR		✓	Blandenet et al., "THIN LAYERS DEPOSITED BY THE PYROSOL PROCESS", Thin Solid Films, vol. 77, pp. 81-90, 1981				

EXAMINER

DATE CONSIDERED

7-13-05

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

From 07/09/1956
AC

